



Recent Advances in Optical Metrology

Guest Editors:

Dr. Yajun Wang

College of Electronics and
Information Engineering, Sichuan
University, Chengdu 610065,
China

Dr. Jae-sang Hyun

School of Mechanical
Engineering, Yonsei University,
Seoul 03722, Republic of Korea

Dr. Yuwei Wang

School of Engineering, Anhui
Agricultural University, Hefei
230036, China

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Message from the Guest Editors

Dear Colleagues,

With the advances in scientific and technological development, optical metrology has been widely applied in various applications such as industrial inspection, biomedical imaging, experimental mechanics, smart agriculture, and consumer entertainment. Based on the hardware devices and working principles, optical metrology can be divided into numerous different types: structure light, laser interferometry, holographic interferometry, digital holography, stereo vision, time of flight, etc. In recent years, many scholars have developed various advanced techniques for optical metrology and applied these advanced techniques into new application scenarios. This Special Issue focuses on, but is not limited to, the most up-to-date optical metrology and their applications.

Prof. Dr. Yajun Wang

Dr. Jae-sang Hyun

Dr. Yuwei Wang

Guest Editors





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Editor-in-Chief

Prof. Dr. Nelson Tansu

School of Electrical and
Electronic Engineering (EEE), The
University of Adelaide, Adelaide,
SA 5005, Australia

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MDPI, Grosspeteranlage 5
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